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CONFIRMATION NO. 4537

SERIAL NUMBER 10/628,803	FILING DATE 07/28/2003  RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 29936/39432	
<b>APPLICANTS</b>  Sung Hoon Lee, Seoul, KOREA, REPUBLIC OF;  ** CONTINUING DATA ***** <i>None</i>  ** FOREIGN APPLICATIONS ***** <i>Yes</i> REPUBLIC OF KOREA 2002-85460 12/27/2002  IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/05/2004					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>Allowance</i> Examiner's Signature <i>LV</i> Initials		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 3	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 1
<b>ADDRESS</b> 04743 MARSHALL, GERSTEIN & BORUN LLP 233 S. WACKER DRIVE, SUITE 6300 SEARS TOWER CHICAGO , IL 60606					
<b>TITLE</b> Method of forming isolation film of semiconductor device					
FILING FEE  RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )		